# IAP9 Rec'd PCT/PTO 03 FEB 2006

Docket No. 285545US2X PCT

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

Charles S. J. PICKLES, et al.

SERIAL NO:

New U.S. PCT Application Based on PCT/IB04/02404

GAU:

FILED:

Herewith

**EXAMINER:** 

FOR:

DIAMOND MICROELECTRODES

## **INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97**

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR

Applicant(s) wish to disclose the following information.

#### REFERENCES

The applicant(s) wish to make of record the references cited in the International Search Report and listed on the
 attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of
relevancy or any readily available English translations of pertinent portions of any non-English language
references

☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

#### RELATED CASES

П	Attached is a list of applicant's pending application(s), published application(s) or issued patent(s) which may be
ш	related to the present application. In accordance with the waiver of 37 CFR 1.98 dated September 21, 2004, copies
	related to the present application. In accordance with the water of the present application. In accordance with the water of the present application.
	of the cited pending applications are not provided. Cited published and/or issued patents, if any, are listed on the
	attached PTO form 1449.

☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

#### CERTIFICATION

Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of
this statement

□ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

#### **DEPOSIT ACCOUNT**

Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit account number <u>15-0030</u>. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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Form PTO 1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY DOCKET NO.		SERIAL NO. New U.S. PCT Application Based on PCT/IB04/02404				
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EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB FILING DATE CLASS IF APPROPRIATE				
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	AZ			-	Addi	tional Refe	erences	sheet(s) attached		
Examiner	Examiner Date Considered									
				t citation is in conformance with MPEP 60 n with next communication to applicant.	9; Draw lir	ne through	citation	if not in		